2622 PATENT 6-11-02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

e Application of:

JUN 0 3 2002

Javentors:

Andrew Rodney Earlitsch, Mary

Louise Bourret, and Jerry Steven

Orleck

Serial No:

09/964,985

Filed:

September 26, 2001

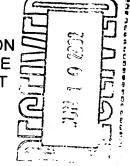
Title:

METHODS AND SYSTEMS FOR

PRINTING DEVICE LOAD-

**BALANCING** 

INFORMATION DISCLOSURE STATEMENT



Attorney Docket No. SLA1004

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## CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited in the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Washington D.C. 2023 on May 24, 2002

Scott C. Krieger, Reg. No. 42,798 Signature Date: May 24, 2002

Commissioner for Patents Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97(b)

Sir:

Applicants herewith submit information in the above-identified application for consideration by the Examiner. A first Office Action on the merits not having been received, applicants submit this information under 37 C.F.R. §1.97(b)(3).

The information is listed on attached Form PTO-1449 and is submitted pursuant to 37 C.F.R. §1.56. A copy of each listed publication is submitted. The foreign patent documents listed herewith are accompanied by the Englishlanguage translations of the abstracts as provided by the Japanese Patent Office. These English-language abstracts may be referred to for a statement of relevance of the associated documents. The inventors, attorney, and any others substantially involved in the preparation or prosecution of this U.S. application are only aware of information in the English-language abstracts and graphical information in the figures of the references.

Applicants respectfully request that the listed information be considered by the Examiner and made of record in the above-identified application.

The Commissioner is hereby authorized to charge any additional fees associated with this communication, or credit any overpayment, to Deposit Account No. 50-0803. A duplicate copy of this authorization is enclosed.

May 24, 2002

Respectfully submitted,

Scott C. Krieger, Patent Counsel Sharp Laboratories of America, Inc. 5750 NW Pacific Rim Boulevard Camas, WA 98607

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FORM PTO-1449

INFORMATION DISCLOSURE CITATION IN AN APPLICATION



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DOCKET NUMBER SLA1004 APPLICATION NUMBER 09/964,985

APPLICANT

Andrew Rodney Ferlitsch, Mary Louise Bourret, and Jerry Steven Orleck

FILING DATE:

GROUP ART UNIT

2622

## **U.S. PATENT DOCUMENTS**

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